

Notice of References Cited	Application/Control No. 10/645,582		Applicant(s)/Patent Under Reexamination KOMURO ET AL.	
	Examiner Tai Van Nguyen		Art Unit 3729	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,109,734	08-2000	Kashino et al.	347/65
*	B	US-5,030,317	07-1991	Noguchi, Hiromichi	216/27
*	C	US-4,775,445	10-1988	Noguchi, Hiromichi	216/27
*	D	US-5,478,606	12-1995	Ohkuma et al.	427/555
*	E	US-5,758,417	06-1998	Kobayashi et al.	29/890.1
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
*	N	JP 06-143578	05-1994	Japan	Hayashi Kazuhiro et al.	B41J 2/05
*	O	JP 09-011469	01-1997	Japan	Izumida Masaaki et al.	B41J 2/05
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.